



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Akihiko OTOGURO et al.**

Group Art Unit: **2822**

Serial No.: **10/603,077**

Examiner: **Christy L. Novacek**

Filed: **June 25, 2003**

Confirmation No.: **1877**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND  
METHOD OF FORMING PATTERN**

Attorney Docket Number: **030757**

Customer Number: **38834**

**RESPONSE UNDER 37 C.F.R. § 1.116**  
**EXPEDITED PROCESSING REQUESTED**

**BOX AF**

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

Date: March 28, 2005

Sir:

In response to the Office Action dated December 28, 2004, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.